Docket No.: 21302/0204309-US0

Examiner: Crawford, L. N.

(PATENT)

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Euijoon Yoon et al.

Application No.: 10/596,126 Confirmation No.: 2554

Filed: May 31, 2006 Art Unit: 2813

For: GROWTH METHOD OF NITRIDE

SEMICONDUCTOR LAYER AND LIGHT EMITTING DEVICE USING THE GROWTH

**METHOD** 

VICE USING THE GROWTH

## AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

MS Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

## **INTRODUCTORY COMMENTS**

In response to the Office Action dated October 18, 2007, please amend the above-identified U.S. patent application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 6 of this paper.

Remarks/Arguments begin on page 11 of this paper.